

AMENDMENTS TO THE SPECIFICATION

Please amend the title as follows:

Delete "PATTERN DEFINITION OF MRAM DEVICE USING CHEMICAL MECHANICAL POLISHING " and insert – METHODS OF FABRICATING AN MRAM DEVICE USING CHEMICAL MECHANICAL POLISHING -- in its place.

Immediately after the heading "FIELD OF INVENTION" on page 1 of the specification, add the following:

--This application is a continuation of U.S. Patent Application 10/119,952, filed on April 11, 2002 (allowed). --